

Attorney Docket No. 071469-0309182
Client Reference: PC6042A2

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **SIDDHARTHA PANDA, AELAN MOSDEN, RICH WISE, KENRO
SUGIYAMA, and JOSEPH GREGORY CAMILLERI**

Application No.:		Confirmation No:
Filed:	April 9, 2004	Group No.:
		Examiner
For:	METHOD AND SYSTEM FOR DEEP TRENCH SILICON ETCH	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: **SIDDHARTHA PANDA**
Citizenship: **INDIA**
Residence: **Beacon, NY 12508**

Second applicant: **AELAN MOSDEN**
Citizenship: **USA**
Residence: **Poughkeepsie, NY 12603**

Third applicant: **RICH WISE**
Citizenship: **USA**
Residence: **New Windsor, NY 12553**

Fourth applicant: **KENRO SUGIYAMA**
Citizenship: **JAPAN**
Residence: **Cambridge, MA 02138**

Fifth applicant: **JOSEPH GREGORY CAMILLERI**
Citizenship: **USA**
Residence: **Wappingers Falls, NY 12590**

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: **METHOD AND SYSTEM FOR DEEP TRENCH SILICON ETCH**

Docket number assigned to this application: 071469-0309182

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 12

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Domestic Priority information

Domestic priority for this application is claimed as follows:

35 U.S.C. § 119(e):

Application No.: 60/464,959

Filed: April 24, 2003

Status: pending

Relationship: priority

6. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited

3-6, Akasaka 5-chome, Minato-ku

Tokyo, 107

JAPAN

Extent of interest of assignee in application: 50%

International Business Machines Corporation

New Orchard Road

Armonk, NY 10504

Extent of interest of assignee in application: 50%

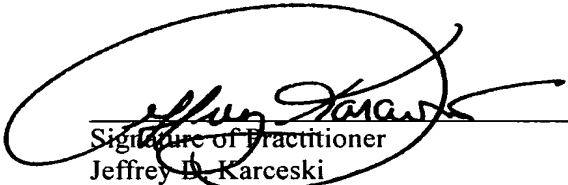
Date: April 9, 2004

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